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Attorney Docket No. 080542-0153

TC 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Shinichiro KOTAKE, et al.

Title: FLUE GAS TREATING SYSTEM AND PROCESS

Appl. No.: 09/658,928

Filing Date: September 11, 2000

Examiner: Timothy C. Vanoy

Art Unit: 1754

REPLACEMENT FORMAL DRAWINGS

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Attached hereto are replacement formal drawings Figures 9 and 10. The reference to "Related Art" has been changed to "Prior Art". In accordance with MPEP § 608.029(v), because this is a mere change in the reference characters, a sketch showing the correction of the drawings does not have to be filed.

Respectfully submitted,

Date: January 2, 2004

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Should additional fees be necessary in connection with the filing of this paper, or if a petition for extension of time is required for timely acceptance of same, the Commissioner is hereby authorized to charge Deposit Account No. 19-0741 for any such fees; and applicant(s) hereby petition for any needed extension of time.